

FIG. 1

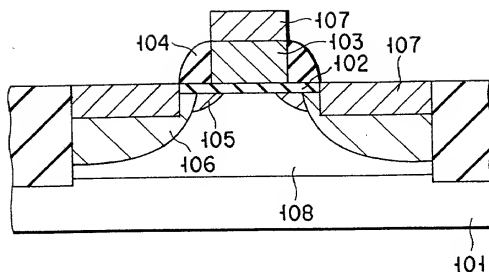


FIG. 2

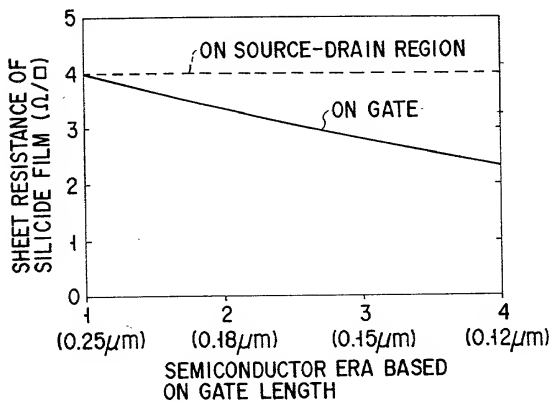
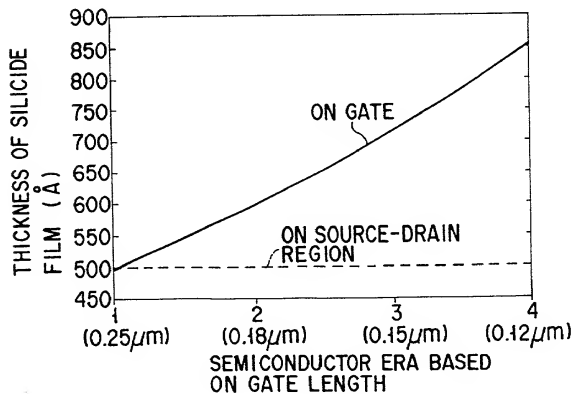


FIG. 3



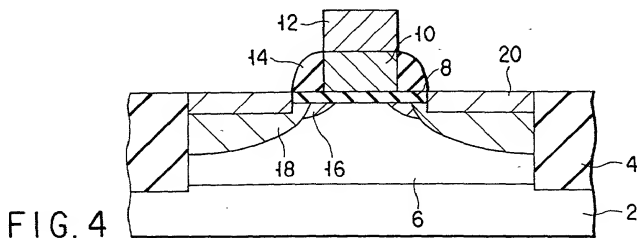


FIG. 4

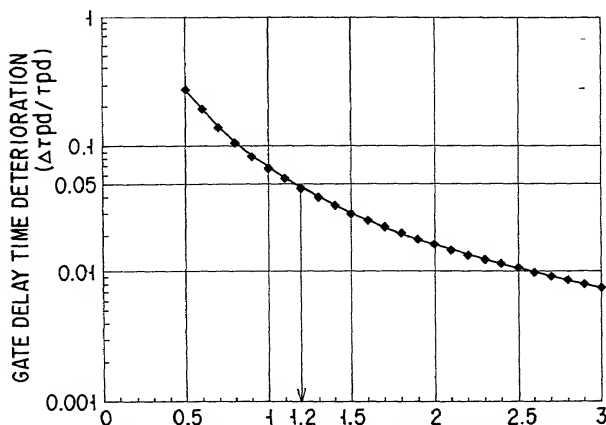


FIG. 5

RATIO OF SILICIDE FILM THICKNESS ON GATE ELECTRODE TO SILICIDE FILM THICKNESS ON SOURCE-DRAIN ELECTRODE (T_g/T_{sd})

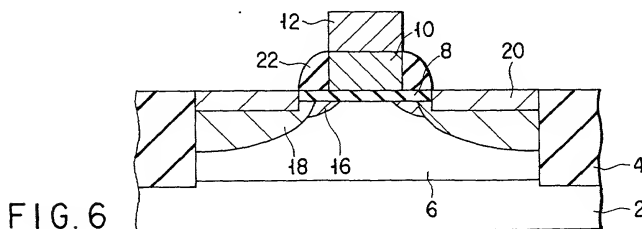
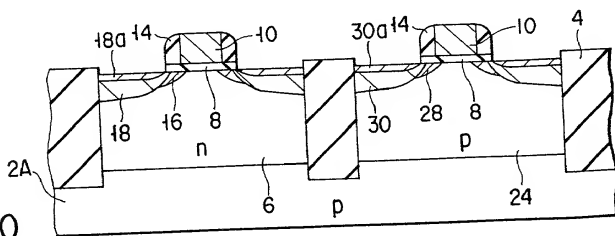


FIG. 6



100620 02591660

FIG. 11

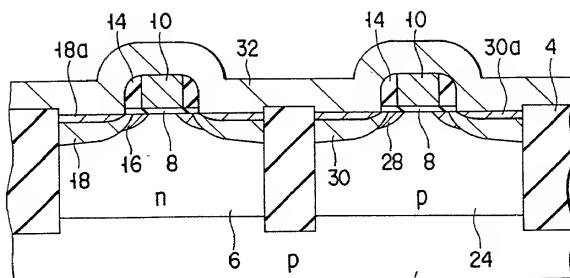


FIG. 12

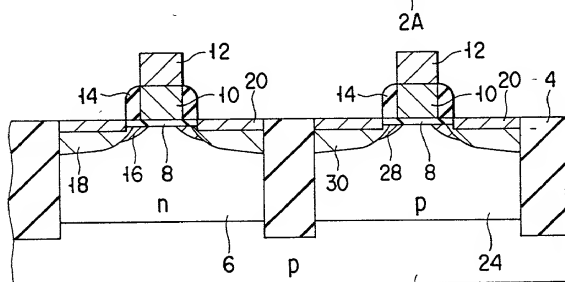


FIG. 13

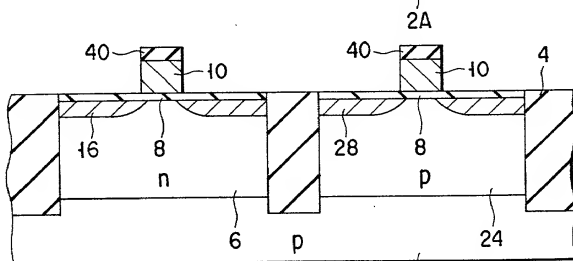
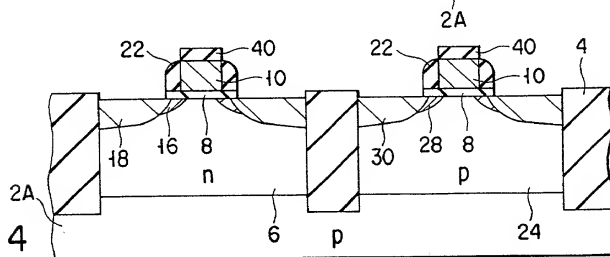
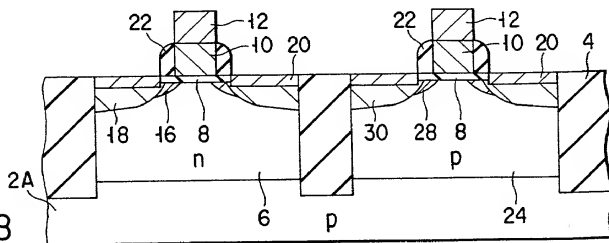
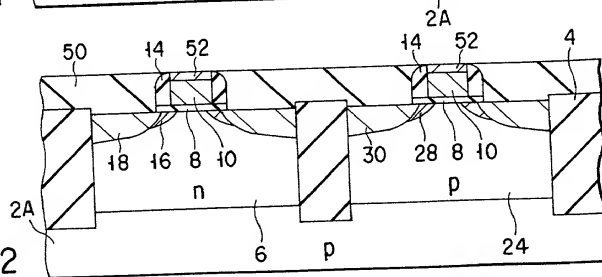


FIG. 14







00015730 02501600

FIG. 23

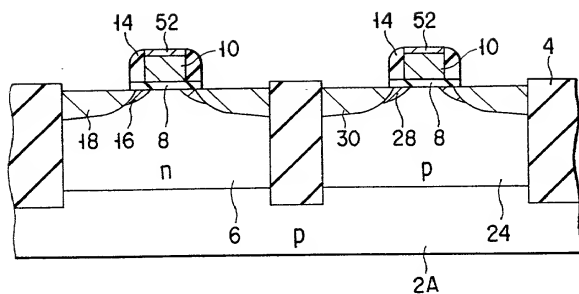


FIG. 24

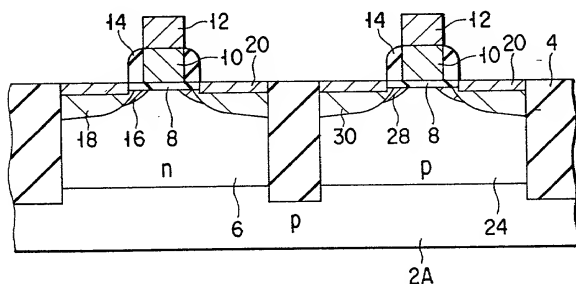


FIG. 25

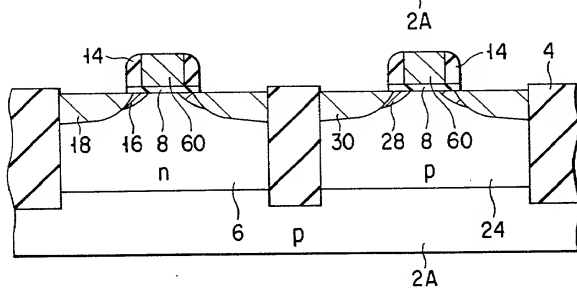
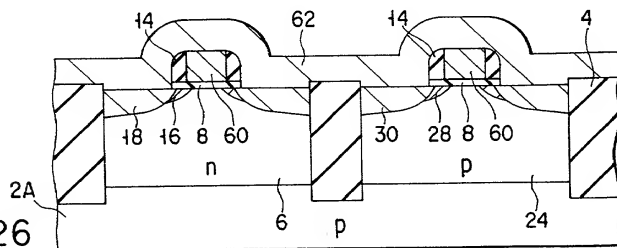


FIG. 26



00916520 073004 1002240 02591620

FIG. 27

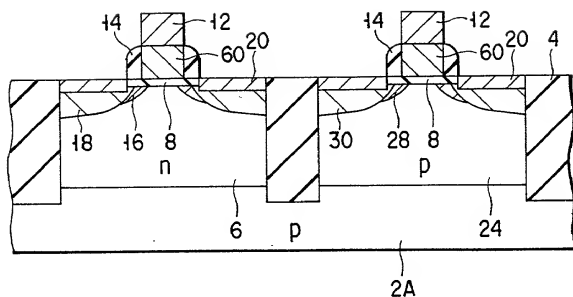


FIG. 28

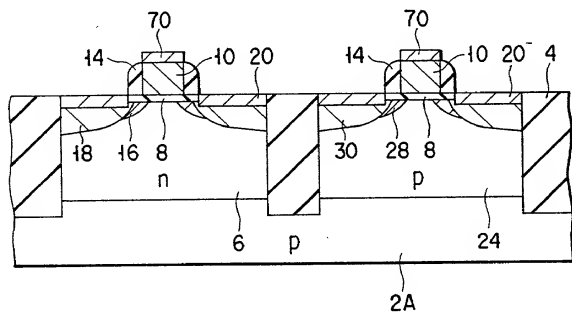


FIG. 29

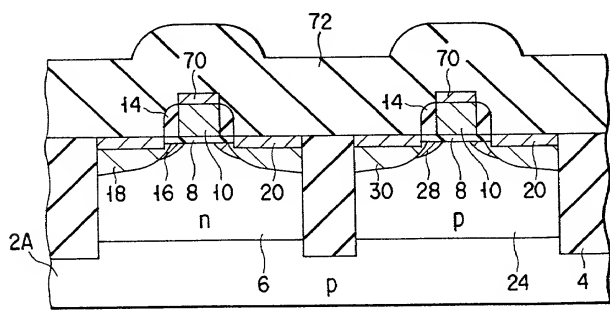


FIG. 30

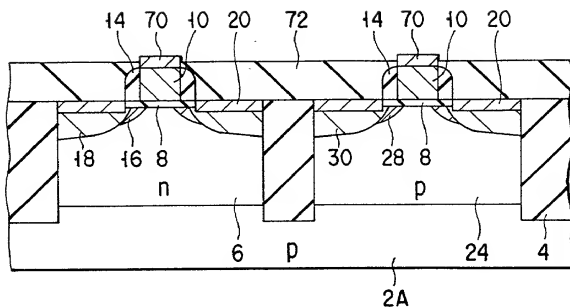


FIG. 31

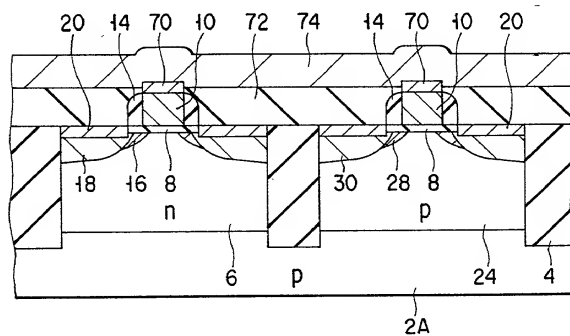


FIG. 32

